

Notice of References Cited	Application/Control No. 10/550,009		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2003/0012133	01-2003	Jappinen, Teemu	370/395.1
*	C	US-2003/0081592	05-2003	Krishnarajah et al.	370/352
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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